

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Confirmation No.: 2927
Osamu NAKAMURA	)	Group Art Unit: 1716
Application No.: 10/807,472	)	Examiner: Rakesh Kumar DHINGRA
Filed: March 24, 2004	)	
For: PLASMA TREATMENT APPARATUS	)	Date: <u>April 22, 2010</u>

**RESPONSE TO FINAL OFFICE ACTION**

**MAIL STOP: RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 22, 2009, Applicants respectfully request reconsideration and allowance of the above-identified application in view of the following amendments and remarks. A petition for a one-month extension of time in accordance with 37 C.F.R. 1.136(a), including the fee required under 37 C.F.R. 1.17(a), is being filed concurrently herewith extending the due date for reply to April 22, 2010. A request for continued examination in accordance with 37 C.F.R. 1.114, including the fee under 37 C.F.R. 1.17(e), is also being filed concurrently herewith for the entry and consideration of this reply.